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(54) Title: OPTICAL PRESSURE SENSOR

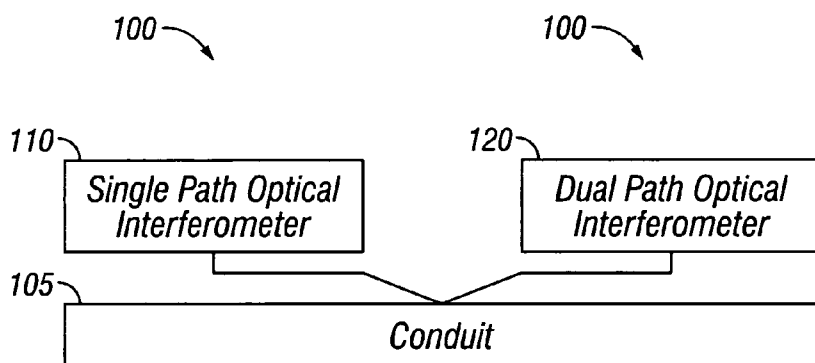


FIG. 1

(57) Abstract: Various embodiments include apparatus and methods of measuring pressure within pipes implemented in a well drilling operation. Methods and apparatus may include a single path optical interferometer having a sensing portion attachable to a location on a conduit and a dual path optical interferometer having a sensing portion attachable to the conduit, where the sensing portions are effectively collocated. Additional apparatus, systems, and methods are disclosed.

